



EV 549896578

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/928,257
Filing DateAug 10, 2001
Inventor..... Guo et al.
Group Art Unit2671
Examiner Nguyen, K.
Attorney's Docket No. MS1-0952US
Title: Macrostructure modeling with microstructure reflectance slices

RULE 312 AMENDMENT

To: Mail Stop Issue Fee
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Office of Patent Publication/Publishing Division

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As requested by the Office of Patent Publication/Publishing Division, Applicant submits a mere formal correction to a clerical or typographical error in the **"Brief Description of the Drawings."** At Applicant's page 6, paragraph number [0024], under Brief Description of the Drawings, please amend the single letter ("b" to "a") as indicated below:

Figures 9a-9c are computer renderings, where Figure 9a is planar view of a lumislice, Figure 9b is a sample of three (3) of the lumislice of Figure ~~[[9b]]~~ 9a in perspective view, and Figure 9c is sweeping sampling of the lumislice of Figure 9a along and about an axis.

This correction does not add new matter or change the scope of the specification.

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Date: 8/26/05

Respectfully Submitted,

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